

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q82315

Michel PUECH, et al.

Appln. No.: 10/500,654

Group Art Unit: 1765

Confirmation No.: 2879

Examiner: Mahmoud DAHIMENE

Filed: July 2, 2004

For: A METHOD AND APPARATUS FOR ANISOTROPICALLY ETCHING SILICON
WITH A HIGH ASPECT RATIO

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of three months, extending the time for responding to the Office Action of June 15, 2006 to December 15, 2006.

Please charge the statutory fee of \$1020.00 to Deposit Account No.: 19-4880. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

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WASHINGTON OFFICE

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CUSTOMER NUMBER

Respectfully submitted,


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Date: December 12, 2006